

U.S. UTILITY Patent Application

PATENT NUMBER and
ISSUE DATE

APPL NO/M 10034497	FILING DATE 12/28/2001	CLASS 438	SUBCLASS	GAU 2814	EXAMINER QUACH, T
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**CONTINUING DATA VERIFIED:

FOREIGN APPLICATIONS VERIFIED:
REPUBLIC OF KOREA 2001-54511 09/05/2001

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PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>	
Foreign priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no		ATTORNEY DOCKET NO	
35 USC 119 conditions met <input type="checkbox"/> yes <input type="checkbox"/> no		CU-2756 VE	
Verified and Acknowledged Examiners's initials			
TITLE : Method of forming a contact for a semiconductor device			

U.S. DEPT. OF COMM./PAT. & TM./PTO-436 (Rev. 12-94)

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claims for 0.6
ISSUE FEE		DRAWING	
Amount Due	Date Paid	Sheets Drawg.	Figs. Drawg. Print Fig.
<input type="checkbox"/> TERMINAL DISCLAIMER		Application Examiner	
		PREPARED FOR ISSUE	
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